

Applicat	ion/Co	ntrol	No.

10/520,068

TANAKA ET AL.

Applicant(s)/Patent under Reexamination

Examiner

Art Unit

Timothy C. Vanoy

1793

SEARCHED			
Class	Subclass	Date	Examiner
423	593.1	1/8/2008	тс∨
423	594.1	1/8/2008	TCV
423	594.2	1/8/2008	TCV
423	594.3	1/8/2008	TCV
423	594.4	1/8/2008	TCV
423	594.5	1/8/2008	TCV
423	594.6	1/8/2008	TĊV
423	595	1/8/2008	TCV
423	596	1/8/2008	TCV
. 423	598	1/8/2008	TCV
423	599	1/8/2008	TCV
423	600	1/8/2008	TCV
423	594.8	1/8/2008	TCV
423	594.12	1/8/2008	TCV

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
423	593.1	1/8/2008	TCV
423	594.1	1/8/2008	TCV
423	594.2	1/8/2008	TCV
594.6,595,	594.4,594.5, 596,598,599, nd 594.8	1/8/2008	тс∨

SEARCH NO (INCLUDING SEARCH)
·	DATE	EXMR
Inventor name search conducted.	1/8/2008	TCV
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Interference also searched for 423/594.12	1/8/2008	TCV

Search Note	s (continued)
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SEARCHED			
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423	594.13	1/8/2008	TCV
423	594.14	1/8/2008	TCV
423	594.16	1/8/2008	TCV
423	263	1/8/2008	TCV
502	525	1/8/2008	TCV

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
423	594.13	1/8/2008	TCV
423	594.14	1/8/2008	TCV
423	594.16	1/8/2008	TCV
423/263; 502/525		1/8/2008	тсv

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
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